THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application Serial No	
Filing Date	October 21, 1999
Inventor	
Assignee	Micron Technology, Inc.
Group Art Unit	2812
Examiner	H. Tsai
	MI22-1243
	Methods of Forming Devices on a Substrate,
Forming Device Arrays on a	a Substrate, Forming Conductive Lines on a
Substrate, and Forming	Capacitor Arrays on a Substrate, and
Integrated Circuitry	

RESPONSE TO DECEMBER 12, 2001 OFFICE ACTION

To:

Box Fee Amendment

Assistant Commissioner for Patents

Washington, D.C. 20231

From:

Frederick M. Fliegel, Ph.D.

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Wells St. John P.S.

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Responsive to the Office Action dated December 12, 2001, Applicant remarks as follows:

AMENDMENTS

There are no amendments to the specification or claims.

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